



Application No. 10/813,439
SEC.1140
AMENDMENT
May 30, 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of :
Sung-Sok Choi : Group Art Unit 1763
Serial No. 10/813,439 : Examiner Zervigon, Rudy
Filed March 31, 2004 :

Title: APPARATUS AND SYSTEM FOR, AND METHOD OF SUPPLYING PROCESS GAS IN
SEMICONDUCTOR DEVICE MANUFACTURING EQUIPMENT

AMENDMENT

U.S. Patent and Trademark Office
Customer Window, Mail Stop Amendment
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

In response to the Office Action dated November 30, 2006, the period for response having been extended by a Petition for Extension of Time attached herewith, the following amendments and remarks are submitted:

Amendments to the Claims are reflected in the Listing of Claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.